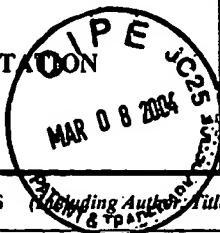


**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)



Docket Number (Optional) <b>50060-00047</b>	Application Number <b>09/966,963</b>
Applicant(s) <b>Miller et al.</b>	
Filing Date <b>September 27, 2001</b>	Group Art Unit <b>2834</b>

*EXAMINER INITIAL	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
W	A. "MULTIPLE SOLUTIONS IN ELECTROSTATIC MEMS" J.A. Pelesko, Modeling and Simulation of Microsystems, 1/2001 (Pgs. 290-293)
W	B. "OPTICAL MEMS DESIGN FOR TELECOMMUNICATIONS APPLICATIONS" Vladimir A. Aksyuk et al., Solid-State Sensor, Actuator and Microsystems Workshop, Hilton Head Island, South Carolina) 2002 (pgs. 1-6)
W	C. "MICROELECTROMECHANICAL SYSTEMS LABORATORY MANUAL", NJIT PHYS 482 and Columbia ME4312, Prof. Farmer (NJIT) and Prof. Mode (Columbia), (Pgs. 1-17) 7/2004
W	D. "AN ANGLE BASED DESIGN APPROACH FOR RECTANGULAR ELECTROSTATIC TORSION ACTUATORS", Zhixiong Xiao et al., New Jersey Institute of Technology, Microelectronics Research Center, (Pgs. 1-27) 12/2001
W	E. "MEMS TECHNOLOGIES FOR OPTICAL APPLCIATIONS", Dr. Veljko Milanovic, Adriatic Research Institute 2002 12/2002
EXAMINER <i>Paul Z...</i>	DATE CONSIDERED <i>5/4/04</i>

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.